



IPW

PATENT
Customer No. 22,852
Attorney Docket No. 2887.0259-00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Junji SUGAMOTO et al.)	Group Art Unit: 2825
)	
Application No.: 10/706,090)	Examiner: LEE, Granvill D
)	
Filed: November 13, 2003)	
)	
For: SEMICONDUCTOR.WAFER)	Confirmation No.: 7292
TREATMENT METHOD,)	
SEMICONDUCTOR WAFER)	
INSPECTION METHOD,)	
SEMICONDUCTOR DEVICE)	
DEVELOPMENT METHOD AND)	
SEMICONDUCTOR DEVICE)	
TREATMENT APPARATUS)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed September 17, 2004, the period for response extending through December 17, 2004, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.